



IPN

AMENDMENT TRANSMITTAL LETTER			Docket No. 0171-1098PUS1	
Application No. 10/849,197-Conf. #7290		Filing Date May 20, 2004	Examiner J. S. Y. Chu	Art Unit 1752
Applicant(s): Takeru WATANABE et al.				
Invention: BASIC COMPOUND, RESIST COMPOSITION AND PATTERNING PROCESS				
<b>MS Amendment</b> Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450  Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.				
<b>CLAIMS AS AMENDED</b>				
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate
Total Claims	15	- 20 =		x
Independent Claims	9	- 9 =		x
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>				
Other fee (please specify):				
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>				0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity				
<input checked="" type="checkbox"/> No additional fee is required for this amendment.				
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.				
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.				
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.				
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>02-2448</u> as described below. A duplicate copy of this sheet is enclosed.				
<input checked="" type="checkbox"/> Credit any overpayment.				
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.				
Gerald M. Murphy, Jr. Attorney Reg. No.: 28,977			Dated: <u>July 8, 2005</u>	
BIRCH, STEWART, KOLASCH & BIRCH, LLP 8110 Gatehouse Rd Suite 100 East P.O. Box 747 Falls Church, Virginia 22040-0747 (703) 205-8000				



Docket No.: 0171-1098PUS1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Takeru WATANABE et al.

Application No.: 10/849,197

Confirmation No.: 7290

Filed: May 20, 2004

Art Unit: 1752

For: BASIC COMPOUND, RESIST COMPOSITION  
AND PATTERNING PROCESS

Examiner: J. S. Y. Chu

**REPLY UNDER 37 C.F.R. 1.111**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 8, 2005

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated June 10, 2005, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.